

Notice of References Cited

Application/Control No.

10/562,080

Applicant(s)/Patent Under
Reexamination
DEGUCHI ET AL.

Examiner

Mark John Stevenosky, Jr.

Art Unit

2853

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,880,916	04-2005	Kim, Yun-gi	347/47
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
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NON-PATENT DOCUMENTS

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